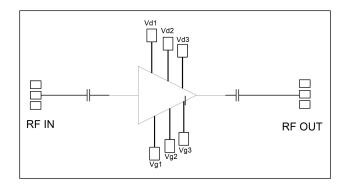


# GaAs MMIC High Dynamic Range Amplifier Chip , 8-12GHz

### Performance characteristics

Frequency range: 8-12GHz Small Signal Gain: 24.5dB Gain flatness: ±1.0dB P-1dB: 28dBm Psat: 28.5dBm Power supply: +8 V/ 135 mA 50Ohm input/output 100% on-chip testing Chip size : 2.53 x 1.52 x 0.1mm

### Functional Block Diagram



#### **Product Introduction**

GPA-0812A is a broadband, high dynamic range, low noise amplifier chip based on GaAs technology, with a frequency range of 8~12GHz, a small signal gain of 24.5dB, and a P-1 output power of 28dBm. The chip is powered by a +8V power supply. The chip through-hole metallization process ensures good grounding, and the back side is metallized, which is suitable for eutectic sintering or conductive adhesive bonding process.

Use restriction parameter <sup>1</sup>			
Maximum drain voltage	+12 V		
Maximum input power	+2 5 dBm		
Operating temperature	-55 ~ + 85 °C		
Storage temperature	-65 ~ +150°C		

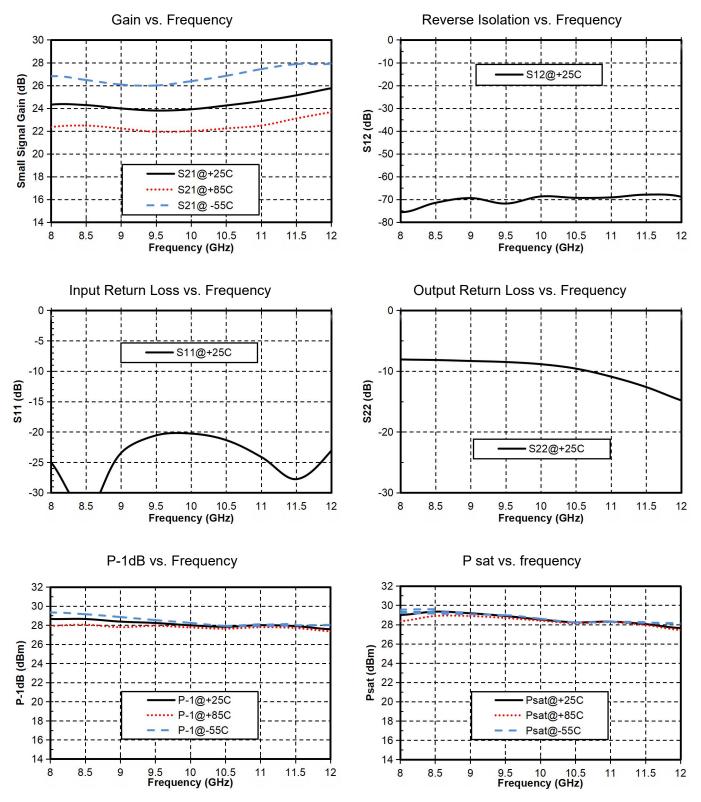
[1] Exceeding any of these maximum limits may cause permanent damage.

Electrical parameters ( TA = +25°C , Vd = +8V, ∗Ids = 135 mA)					
index	Minimum	Typical Value	Maximum	unit	
Frequency Range		8-12		GHz	
Small Signal Gain	23.5	24.5	25.5	dB	
Gain Flatness		± 1.0		dB	
P -1 dB		28		dBm	
Psat		28.5		dBm	
Input return loss		24		dB	
Output return loss		10		dB	
Quiescent Current		135		mA	
efficiency		34~40		%	
*By tuning the Vg terminal voltage from -2V to 0V, the recommended Vg terminal voltage is -0.9V .					



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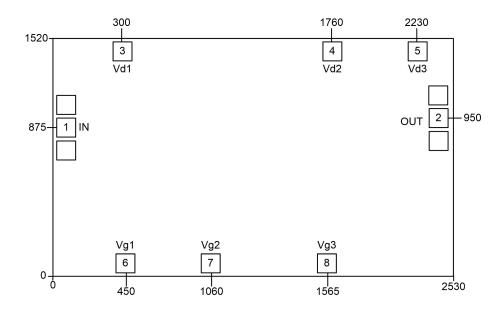
#### Main index test curve





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### Appearance structure <sup>2</sup>



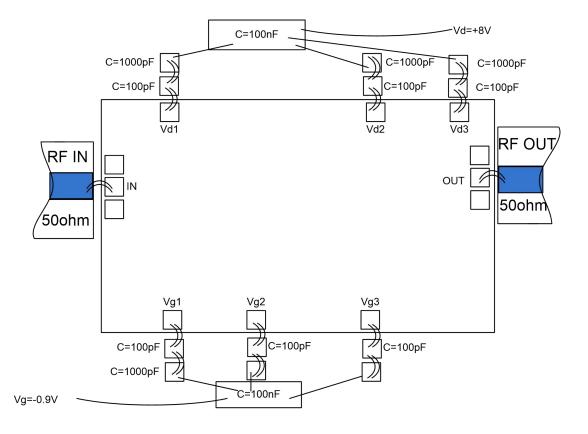
[ 2 ] All units in the figure are micrometers

Bonding point definition				
Bonding point number	Function Symbol	Functional Description		
1	RF IN	RF signal input terminal, no DC blocking capacitor required.		
2	RF OUT	RF signal output terminal, no DC blocking capacitor required.		
3, 4, 5	Vd1 Vd2 Vd3	2 Vd3 Amplifier drain bias, requires external 100 pF, 1000pF, 100nF bypass capacitor.		
6, 7, 8	Vg1 Vg2 Vg3	Amplifier gate bias, external 100 pF, 1000 pF, 100 nF bypass capacitor required.		
Chip bottom	GND	The bottom of the chip needs to be in good contact with the RF and DC grounds.		



### GaAs MMIC High Dynamic Range Amplifier Chip, 8-12GHz

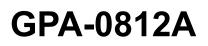
### Recommended assembly diagram



#### Notice

- The chip must be stored in an anti-static container and kept in a nitrogen environment.
- Do not attempt to clean the bare die surface using wet chemical methods.
- Please strictly follow the ESD protection requirements to avoid static damage to the bare chip.
- General operation: Please use precision pointed tweezers to pick up bare chips. Avoid touching the chip surface with tools or fingers during operation.
- Rack mounting operation suggestions: Bare chip mounting can be done by AuSn solder eutectic sintering or conductive adhesive bonding. The mounting surface must be clean and flat.
- Sintering process: It is recommended to use AuSn solder sheets with a gold-tin ratio of 80/20. The working surface temperature reaches 255 °C and the tool (vacuum chuck) temperature reaches 265 °C. When the high-temperature mixed gas (nitrogen-hydrogen ratio of 90/10) is blown to the chip, the temperature at the top of the tool should be raised to 290 °C. Do not let the chip exceed 320 °C for more than 20 seconds. The friction time should not exceed 3 seconds.
- Bonding process: The amount of conductive glue dispensed should be as small as possible. After the chip is placed in the installation position, the conductive glue can be vaguely seen around it. For curing conditions, please follow the information provided by the conductive glue manufacturer.
- Bonding operation suggestions: Use Φ0.025mm (1mil) gold wire for both ball and wedge bonding.





Thermosonic bonding temperature is 150  $^{\circ}$ C. The pressure of the wedge bonding knife is 40~50gf for ball bonding and 18~22gf for wedge bonding. Use the smallest possible ultrasonic energy. The bonding starts at the pressure point on the chip and ends at the package (or substrate).